

# Citations for Target : **Piezo**

<i>Pub. Year</i>	<i>Authors, Title, Journal Citation and Comments</i>	<i>Citation Numb</i>
<b>1976</b>	Hartemann, P. Marizot, M. 'Ion Implantation in Piezoelectric Substrates'	<b>1976-Hart</b>
	<i>Ion Implantation in Semiconductors, Ed. by F. Chernow, J. A. Borders, D. K. Brice, 257-264 (1976)</i> <i>Comment : R. 100 keV He, Li, Be -&gt; Piezoelectric Substrates</i>	1067